# ORIGINAL PAGE IS N85-32412 OF POOR QUALITY SILICON REFINEMENT BY CHEMICAL VAPOR TRANSPORT

#### SOLAR ENERGY RESEARCH INSTITUTE

#### J. Olson

TECHNOLOGY	REPORT DATE
SILICON MATERIALS	OCTOBER 1, 1984
APPROACH VAPOR TRANSPORT PURIFICATION OF SI	STATUS -CASTING OF LARGE ALLOY PLATES HAS BEEN
USING A SI:Cu3SI SOURCE	ACHIEVED -CHARACTERIZATION OF A LARGER RESEARCH
CONTRACTOR SOLAR EHERGY RESEARCH INSTITUTE	SCALE REACTOR IS NEAR COMPLETION -REFINED SILICON PRODUCT HAS BEEN SHOWN
GOALS	TO YIELD SOLAR CELLS WITH NEAR STATE-OF-
STUDY THE OPERATING CHARACTERISTICS OF	THE-ART CONVERSION EFFICIENCIES
THE PURIFICATION PROCESS INCLUDING FACTORS	
AFFECTING THE RATE, THE PURIFICATION  EFFICIENCY, AND THE PHOTOVOLTAIC QUALITY	
OF THE REFINED SILICON	
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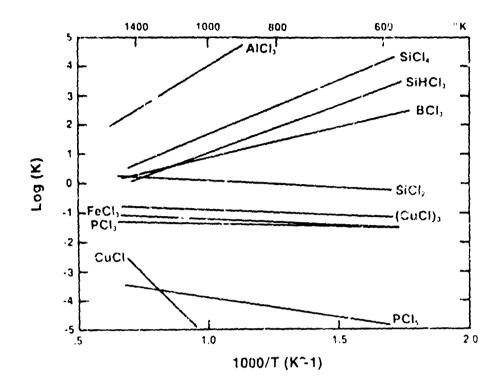
### SILICON MATERIAL

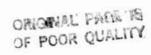
Impurity	mgSi (ppma)	CVT Refined (ppma)
Cu	-	0.12 - 0.15
В	117	< 0.26
P	15	0.16 - 1.8
Al	> 3400	< 0.1 - 0.98
Fe	> 2500	< 0.13 - 0.50
Mn	550	< 3.15
Ca	290	< 0.07 - 0.2
Ti	290	< 0.06
V	250	<b>₹</b> 0.055 <b>- 0.44</b>
Ni	39	· 0.13 <b>- 1.9</b>
Zr	13	0.09
Мо	1.4	0.09

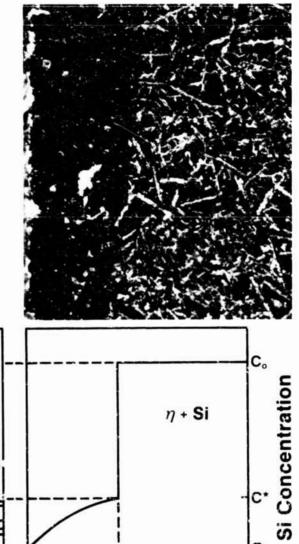
†R. H. Hopkins, et. al. (n-type base) \*p-type base

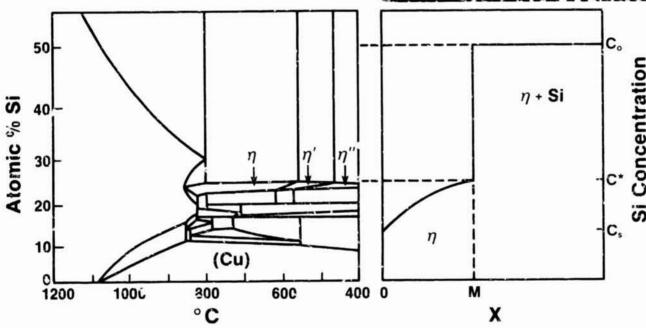
# SILICON MATERIAL

# CVT Transport per Mole HCI

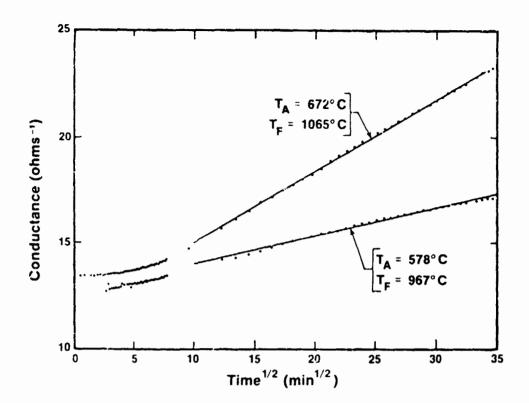








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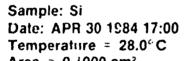
#### SILICON MATERIAL

# **Electronic Properties**

	RECRYSTALLIZED	AS DEPOSITED
RESISTIVITY	0.08.	3.1-1
HALL MOBILITY	524	
No-NA	1.5x10 <sup>17</sup>	

# PHOTOVOLTAIC CHARACTERISTICS (No AR coating)

	VTF REFINED SI	COUTROL CELLS
V <sub>ac</sub> (mV)	622	604
V <sub>ac</sub> (mV) J <sub>sc</sub> (mAcm <sup>-2</sup> )	19.6	19.6
F	0.81	0.81
EFFICIENCY	2.8%	9.6%
EASE RESISTIVITY	9.38	9.2



V<sub>oc</sub> = 0.5945 volts J<sub>sc</sub> = 19.71 mA/cm<sup>2</sup> Fill factor = 79.94% Efficiency = 9.37%

